

NGC-212/12-1167

IN THE UNITED STATES
PATENT AND TRADEMARK OFFICE

Patent Application

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FEB 02 2006

Inventor(s): Raffi Nazare Elmadjian

Case No.: NGC-212/12-1167

Serial No.: 10/688,238

Filing Date: 10/18/2003

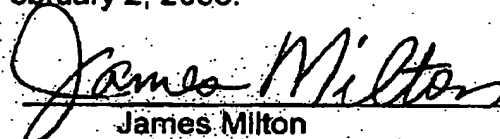
Title: WAFER ETCHING TECHNIQUES

Examiner
Art Unit:

Ken Chan Chin
1765

CERTIFICATE OF FACSIMILE TRANSMISSION

I hereby certify that this correspondence is being sent via facsimile transmission to Commissioner for Patents, Mail Stop Amendment, Group Art Unit 1765, Attention: Examiner Ken Chan Chin, P.O. Box 1450, Alexandria, VA 22313-1450, at fax number (571) 273-8300, on February 2, 2006.



James Milton
Attorney for Applicants
Reg. No. 46,935

Date of Signature: February 2, 2006

Commissioner for Patents
Mail Stop Amendment
Group Art Unit 1765
Attention: Examiner Ken Chan Chin
P.O. Box 1450
Alexandria, VA 22313-1450
Fax Number (571) 273-8300

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AMENDMENT AFTER FINAL OFFICE ACTION

Dear Sir:

This response is being filed in reference to the Final Office Action dated November 10, 2005 in connection with the above-designated application. A response to the Office Action is due February 10, 2006. Therefore, this Response is timely filed.